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APPLICANTS Shinji Omori, Kanagawa, JAPAN; Kaoru Koike, Ibaraki, JAPAN; Shigeru Moriya, Kanagawa, JAPAN; Isao Ashida, Kanagawa, JAPAN; <i>noted</i> <i>MS</i>					
** CONTINUING DATA ** This application is a 371 of PCT/JP03/03455 03/20/2003 <i>noted</i> <i>MS</i>					
** FOREIGN APPLICATIONS ** JAPAN 2002-92612 03/28/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met met Verified and Acknowledged Examiner's Signature <i>Michael Heller</i> Initials <i>MS</i>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 24	TOTAL CLAIMS 26	INDEPENDENT CLAIMS 5
ADDRESS 23353					
TITLE Mask pattern correction method, semiconductor device manufacturing method, mask manufacturing method and mask					
FILING FEE RECEIVED 1200	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		